

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **TAKESHITA, Mitsunori, et al.**

Group Art Unit: **1716**

Serial No.: **10/593,282**

Examiner: **FORD, Nathan K.**

Filed: **April 22, 2008**

P.T.O. Confirmation No.: **8499**

For: **SUBSTRATE PROCESSING APPARATUS AND MANUFACTURING METHOD  
FOR A SEMICONDUCTOR DEVICE**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 26, 2012

Sir:

In response to the Office Action dated October 26, 2011, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.